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Date:

September 22, 2004

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No.

: 09/873,230

Confirmation No. 4487

Applicant

: Norbert Benesch et al.

Filed

June 4, 2001

TC/A.U.

: 2625

Examiner

: John B. Strege

Title:

Method and Device for Optically Monitoring Fabrication Processes of Finely Structured Surfaces in a Semiconductor Production

Docket No.

EHF 2001,0167 P

Customer No.

24131

Hon. Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

## **AMENDMENT**

## Sir:

In response to the Office action dated June 23, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 15 of this paper.

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